

Paper No.: _____

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Inventor(s): CHAPMAN, Glenn H.; SARUNIC, Marinko Venci; TU, Yugiang
Title: **DRY MULTILAYER INORGANIC ALLOY THERMAL RESIST FOR
LITHOGRAPHIC PROCESSING AND IMAGE CREATION**
Serial No.: Unassigned
Filed: Herewith
Date: 17 October 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

**LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE STATEMENT**
[Form PTO-1449 (Modified)]

United States Patent Documents

| Examiner | ID | Patent No. | Issue Date | Inventor(s) | Class | Sub-Cl | Filing Date |
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| SPM | US: 1 | 4,211,838 | 8 July 1980 | Izu et al. | — | — | |
| SPM | US: 2 | 4,082,861 | 4 April 1978 | Izu et al. | — | — | |
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| Examiner | ID | Author, Title, Date, Pertinent Pages, etc. |
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| SRM | OA: 1 | Gelbart and Karasyuk, Proc. SPIE Emerging Lithographic Technologies III, V 3676, pg 786-793 (1999) |
| | OA: 2 | |

Examiner: Mohamedolla

Date Considered: 11/29/04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance **and** not considered. Include copy of this form with next communication to applicant.